

<b>Notice of References Cited</b>	Application/Control No. 10/534,700		Applicant(s)/Patent Under Reexamination WITTMER ET AL.	
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#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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#### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	"PROFIBUS technology and application - system description", Oct. 2002
*	V	Diedrich et al., "Field Device Integration in DCS Engineering using a Device Model", 1998, IEEE, pp.164-168
*	W	P6schmann et al, "Experience with formal methods implementing the PROFIBUS FMS and DP protocol for industrial applications", 1997 IEEE, pp 277-286
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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